

Electronic Acknowledgement Receipt

EFS ID:	1036193
Application Number:	10748076
Confirmation Number:	6886
Title of Invention:	Method and system for immersion lithography
First Named Inventor:	Chia-Hui Lin
Customer Number:	54657
Filer:	Steven E. Koffs/Wanda Staples
Filer Authorized By:	Steven E. Koffs
Attorney Docket Number:	N1085-00240 [TSMC2003-081
Receipt Date:	02-MAY-2006
Filing Date:	30-DEC-2003
Time Stamp:	13:19:37
Application Type:	Utility
International Application Number:	

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Response to Election / Restriction Filed	TSMC20030813ResponseRestrictionRequirement.pdf	102420	no	2

Warnings:	
Information:	
Total Files Size (in bytes):	102420
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